

Inventor Information

Inventor One Given Name::	Yoshiro
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Citizenship Country::	JAPAN
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Inventor Three Given Name::	Tohru
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Citizenship Country::	JAPAN
Inventor Four Given Name::	Toshihiro
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Correspondence Information

Correspondence Customer Number::	25944
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Application Information

Title Line One::	METHOD AND APPARATUS FOR ION
Title Line Two::	ATTACHMENT MASS SPECTROMETRY
Total Drawing Sheets::	10
Docket Number::	109675

Prior Foreign Applications

Foreign Application One::	2000-169644
Filing Date::	June 6, 2000
Country::	JAPAN
Priority Claimed::	YES

Assignee Information

Name of assignee::	ANELVA CORPORATION
Assignee Address Line One::	8-1, Yotsuya 5-chome,
City::	Fuchu-shi
State or Province::	Tokyo
Country::	JAPAN

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